

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiromi OTOMA



Group Art Unit: 2821

Application No.: 10/826,354

Examiner: C. TRAN

Filed: April 19, 2004

Docket No.: 119498

For: SURFACE EMITTING SEMICONDUCTOR LASER AND COMMUNICATION
SYSTEM USING THE SAME

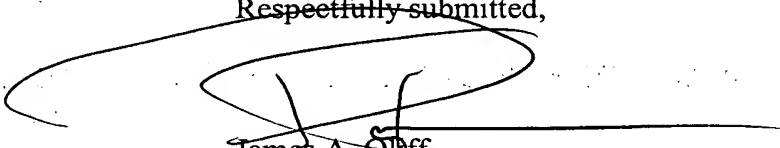
LETTER TO THE OFFICIAL DRAFTSPERSON

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please substitute the attached 4 sheets of formal drawings depicting Figures 1-5 and
10A and 10B for the corresponding drawings filed with the application.

Respectfully submitted,


James A. Oliff
Registration No. 27,075

Paul Tsou
Registration No. 37,956

JAO:PXT/sqb

Date: February 21, 2006

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<p>DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461</p>

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The following papers have been filed:

IDS; Pto 1449 w/7 Refs, 1 abstract & 1 transl; CFP w/cert copy JP 2003-122697 (4-25-2003)

Name of Applicant: Hiromi OTOMA

Serial No.: 10/826,354

Atty. File No.: 119498

Title (New Cases):

Sender's Initials: JAO/mlo

36/20

PATENT OFFICE DATE STAMP



**COPY TO BE STAMPED BY PATENT OFFICE
AND RETURNED BY MESSENGER**

**Oliff & Berridge, PLC
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